

L Number	Hits	Search Text	DB	Time stamp
119	110923	(substrate near1 (silicon (lithium near niobate) (lithium near tantalate) quart))	USPAT; US-PGPUB; EPO; JPO; DERWENT	2003/06/14 15:25
120	12756	((substrate near1 (silicon (lithium near niobate) (lithium near tantalate) quart))) and (transparent window lens) and (microstructure micromechanical microelectronic optoelectronic optical)	USPAT; US-PGPUB; EPO; JPO; DERWENT	2003/06/14 15:31
121	2	((substrate near1 (silicon (lithium near niobate) (lithium near tantalate) quart))) and (transparent window lens) and (microstructure micromechanical microelectronic optoelectronic optical)) and crystalline	USPAT; US-PGPUB; EPO; JPO; DERWENT	2003/06/14 15:05
122	3208	((substrate near1 (silicon (lithium near niobate) (lithium near tantalate) quart))) and (transparent window lens) and (microstructure micromechanical microelectronic optoelectronic optical)) and crystalline	USPAT; US-PGPUB; EPO; JPO; DERWENT	2003/06/14 15:12
123	4	((substrate near1 (silicon (lithium near niobate) (lithium near tantalate) quart))) and (transparent window lens) and (microstructure micromechanical microelectronic optoelectronic optical)) and crystalline) and (csp (chip adj (sized scale) adj package))	USPAT; US-PGPUB; EPO; JPO; DERWENT	2003/06/14 15:24
124	332	((substrate near1 (silicon (lithium near niobate) (lithium near tantalate) quart))) and (transparent window lens) and (microstructure micromechanical microelectronic optoelectronic optical)) and crystalline) and (bump ball csp (chip adj (sized scale) adj package))	USPAT; US-PGPUB; EPO; JPO; DERWENT	2003/06/14 15:09
125	331	((substrate near1 (silicon (lithium near niobate) (lithium near tantalate) quart))) and (transparent window lens) and (microstructure micromechanical microelectronic optoelectronic optical)) and crystalline) and (bump ball)	USPAT; US-PGPUB; EPO; JPO; DERWENT	2003/06/14 15:10
126	165	((substrate near1 (silicon (lithium near niobate) (lithium near tantalate) quart))) and (transparent window lens) and (microstructure micromechanical microelectronic optoelectronic optical)) and crystalline) and (bump ball)) and adhesive	USPAT; US-PGPUB; EPO; JPO; DERWENT	2003/06/14 15:10
127	204	((substrate near1 (silicon (lithium near niobate) (lithium near tantalate) quart))) and (transparent window lens) and (microstructure micromechanical microelectronic optoelectronic optical)) and crystalline) and (bump ball)) and (adhesive epoxy)	USPAT; US-PGPUB; EPO; JPO; DERWENT	2003/06/14 15:11
128	362	((substrate near1 (silicon (lithium near niobate) (lithium near tantalate) quart))) and (csp (chip adj (sized scale) adj package))	USPAT; US-PGPUB; EPO; JPO; DERWENT	2003/06/14 15:25
129	113684	(substrate near1 (crystalline silicon (lithium near niobate) (lithium near tantalate) quart))	USPAT; US-PGPUB; EPO; JPO; DERWENT	2003/06/14 15:25
130	362	((substrate near1 (crystalline silicon (lithium near niobate) (lithium near tantalate) quart))) and (csp (chip adj (sized scale) adj package))	USPAT; US-PGPUB; EPO; JPO; DERWENT	2003/06/14 15:26

131	145	((substrate near1 (crystalline silicon (lithium near niobate) (lithium near tantalate) quart))) and (csp (chip adj (sized scale) adj package))) and (transparent light image lens optoelectronic optical)	USPAT; US-PGPUB; EPO; JPO; DERWENT	2003/06/14 15:38
132	37	((substrate near1 (crystalline silicon (lithium near niobate) (lithium near tantalate) quart))) and (csp (chip adj (sized scale) adj package))) and (microstructure micromechanical microelectronic)	USPAT; US-PGPUB; EPO; JPO; DERWENT	2003/06/14 15:38
133	282	((substrate near1 (crystalline silicon (lithium near niobate) (lithium near tantalate) quart))) near3 (microstructure micromechanical microelectronic micromachine)	USPAT; US-PGPUB; EPO; JPO; DERWENT	2003/06/14 15:38
134	142	((substrate near1 (crystalline silicon (lithium near niobate) (lithium near tantalate) quart))) near3 (microstructure micromechanical microelectronic micromachine)) and (transparent lens optoelectronic optical)	USPAT; US-PGPUB; EPO; JPO; DERWENT	2003/06/14 15:39
135	33	((substrate near1 (crystalline silicon (lithium near niobate) (lithium near tantalate) quart))) near3 (microstructure micromechanical microelectronic micromachine)) and (transparent lens optoelectronic optical)) and cavit\$2	USPAT; US-PGPUB; EPO; JPO; DERWENT	2003/06/14 15:39